



AF
JFW

In re the Application of: **Hirofumi WATATANI**

Group Art Unit: **1765**

Serial No.: **10/685,790**

Examiner: **Kin Chan Chen**

Filed: **October 16, 2003**

Confirmation Number: **7016**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR
DEVICE MANUFACTURING METHOD**

Attorney Docket Number: **032015**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. §1.116
- EXPEDITED RESPONSE -

Mailstop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

October 31, 2005

Sir:

This paper is being filed in response to the Office Action dated September 28, 2005.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.